



35.C12395 CIP

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
YOSHIHIKO FUKUMOTO) : Examiner: Unassigned
Application No.: 09/429,530) : Group Art Unit: 1765
Filed: October 28, 1999) :
For: METHOD FOR FABRICATING) :
SEMICONDUCTOR DEVICE : June 12, 2000

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Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

The listed document was cited in a Korean Search Report dated March 21, 2000, in a Korean patent application corresponding to the above-identified application. A copy of this search report is included.


The concise explanation of relevance for this non-English document is provided in the form of an English language abstract.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


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